



501.41175X00

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

NAKANO, et al

Serial No.:

10/075,244

Filed:

February 15, 2002

For:

METHOD AND APPARATUS FOR PLASMA PROCESSING

Group:

1762

Examiner:

M. Padgett

## RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

June 24, 2004

Sir:

In response to the communication dated June 22, 2004, applicants submit herewith a complete listing of the claims with the proper status identifier, as listed below: